

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/780,761	OKUDA, TATSUO	
Examiner	Art Unit	
YOGESH K. AGGARWAL	2622	

SEARCHED				
Class	Subclass	Date	Examiner	

INTERFERENCE SEARCHED					
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
348/371-376,340,345,396/176- 178,348- 350,D16/200,202,211,209,239,304	6/4/2010	YKA	